

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: S. SHIRAYONE, et al.  
Application No.: 10/791,856  
Filed: MARCH 4, 2004  
For: METHOD FOR PROCESSING PLASMA PROCESSING  
APPARATUS  
Group AU: 1746  
Examiner: Zeinab El Arini  
Confirm. No.: 5252

**AMENDMENT**

**Mail Stop: AMEND – NO FEE**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

September 27, 2007

SIR:

In response to the Office Action dated June 28, 2007, please amend the  
above-identified application as listed below and as set forth on the following pages:

AMENDMENTS TO THE CLAIMS; and

REMARKS are included following the amendments.